

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re Patent Application of:	)	Group Art Unit: 2823
Shunpei YAMAZAKI et al.	)	Examiner: B. Kebede
Serial No. 09/894,125	)	CERTIFICATE OF MAILING I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on September 22, 2003.
Filed: June 29, 2001	)	
For: CRYSTALLINE SEMICONDUCTOR	)	
THIN FILM, METHOD OF	)	
FABRICATING THE SAME,	)	
SEMICONDUCTOR DEVICE, AND	)	
METHOD OF FABRICATING THE	)	TECHNO.
SAME	)	<b>3</b> 0 9

## **AMENDMENT**

Honorable Commissioner of Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Further in response to the Official Action dated May 21, 2003, please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 10 of this paper.